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CONFIRMATION NO. 8349

FILING OR 371(c)	CLASS 324		GROUP ART UNIT 2829		ATTORNEY DOCKET NO. 5731-000014/US/NP			
APPLICANTS Beng Ghee Tan, Singapore, SINGAPORE; ** CONTINUING DATA ******************** This application is a 371 of PCT/SG03/00022 02/05/2003 A ** FOREIGN APPLICATIONS ************************************								
Foreign Priority claimed			DRAWING CLA		CLA	MS	INDEPENDENT CLAIMS 2	
ADDRESS 28997								
TITLE								
Method for detecting and monitoring wafer probing process instability								
S: Authority has been given in Paper to charge/credit DEPOSIT ACCOUNT for following:				☐ All Fees				
			1.16 Fees (Filing)					
			NT	1.17 Fees (Processing Ext. of time)				
			☐ 1.18 Fees (Issue)					
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	DATE 07/20/2005 RULE A ***********************************	DATE 07/20/2005 RULE A ***********************************	DATE 07/20/2005 RULE 324 Singapore, SINGAPORE; A************************************	DATE 07/20/2005 RULE Singapore, SINGAPORE; is a 371 of PCT/SG03/00022 02/05/2003 ATIONS STATE OR COUNTRY SINGAPORE Miner's Signature Initials Signature Signatur	DATE 07/20/2005 RULE Singapore, SINGAPORE; is a 371 of PCT/SG03/00022 02/05/2003 ATIONS TO yes no Met after COUNTRY SINGAPORE Initials STATE OR COUNTRY SINGAPORE SINGAPORE To charge/credit DEPOSIT ACCOUNT for following:	DATE 07/20/2005 RULE 324 GROUP ART UNIT 2829 A***********************************	DATE 07/20/2005 RULE CLASS 324 GROUP ART UNIT 2829 5731 A***********************************	